Initial Information Data Sheet

Inventor Information

Inventor One Given Name:

Family Name:

Name Suffix:

Postal Address Line One

Postal Address Line Two

City:

State or Province: Postal or Zip Code: Citizenship Country: Masaki

KUROKAWA

c/o ADVANTEST CORPORATION

1-32-1 Asahi-cho, Nerima-ku

Tokyo

Japan 179-0071

Japan

Correspondence Information

Name Line One:

Name Line Two:

Address Line One:

Address Line Two:

City:

State or Province: Postal or Zip Code:

Telephone:

Fax:

Electronic Mail:

David L. Fehrman

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555 W. 5th Street

35th Floor

Los Angeles

California

90013

213-892-5601

213-892-5454

DFehrman@mofo.com

Application Information

Title Line One:

Title Line Two: Title Line Three: Title Line Four:

Total Drawing Sheets: Formal Drawings?: Application Type:

Docket Number:

ELECTRON BEAM

EXPOSURE APPARATUS AND FABRICATION METHOD OF

ELECTRONIC DEVICE

4 No

Non-provisional 514802001300

Representative Information

Representative Customer Number:

PATENT TRADEMARK OFFICE

Continuity Information

This application is a: > Application One:

Filing Date:

which is a:

>>Application Two:

Filing Date:

which is a:

>>>Application Three:

Filing Date:

Prior Foreign Applications

Foreign Application One: 2001-370545

Filing Date: December 4, 2001

Country: Japan Priority Claimed: Yes

Foreign Application Two: 2001-376423

Filing Date: December 10, 2001

Country: Japan Priority Claimed: Yes

Assignee Information

Assignee: ADVANTEST CORPORATION